

Notice of References Cited	Application/Control No. 10/022,729		Applicant(s)/Patent Under Reexamination PARK ET AL.	
	Examiner Andrew C. Lee		Art Unit 2616	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,625,472	09-2003	Farazmandnia et al.	455/557
*	B	US-6,230,012	05-2001	Willkie et al.	455/435.1
*	C	US-6,483,822	11-2002	Liroy et al.	370/329
*	D	US-6,721,555	04-2004	Phillips et al.	455/411
*	E	US-2004/0029638	02-2004	Hytcheson et al.	463/42
*	F	US-2003/0031302	02-2003	Resuta, David P.	379/27.02
*	G	US-6,185,420	02-2001	Choi, Hyuk-Jung	455/423
*	H	US-7,006,963	02-2006	Maurer, Max M.	703/21
*	I	US-6,119,167	09-2000	Boyle et al.	709/234
*	J	US-2002/0049059	04-2002	Soininen et al.	455/439
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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